

APR 27 2006

SHEET 1 OF 1

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEDOCKET NO.
285507US0PCTSERIAL NO.
10/566,652

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT
Tadaaki KANEKO, et al.FILING DATE
February 1, 2006

GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
J/L	AA 5 383 981	01/24/95	DE PRUNEDA, Jean A. H			
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					
	AM					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES	NO
J/L	AN 6-49619	02/22/94	JP (equivalent of US5 372 655)		NO
J/L	AO 56-79449	06/30/81	JP (equivalent of US4 333 226)		NO
J/L	AP 6-87656	03/29/94	JP		NO
J/L	AQ 2000-44222	02/15/00	JP		NO
J/L	AR 8-64110	03/08/96	JP		NO
J/L	AS 7-330351	12/19/95	JP		NO
J/L	AT 10-245285	09/14/98	JP		NO
J/L	AU 2000-265274	09/26/00	JP		NO
J/L	AV 11-116399	04/27/99	JP		NO

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

J/L	AW	ROCHER, M. et al., "Modelling of the growth of carbide layers in tantalum", Key Engineering Materials, Vols. 206-213, Part 1, Pages 527-530, 2002.	
J/L	AX	KHARATYAN, S.L. et al., "Kinetics of Tantalum Carbidization", Soviet Journal of Chemical Physics, Vol. 8, Part 8, Pages 1881-1892, 1991.	
J/L	AY	TSUTSUMOTO, Takahiro et al., "Improvement of Ta filament for diamond CVD", Thin Solid Films, Vol. 317, Pages 371-375, 1998.	
	AZ	<input type="checkbox"/> Additional References sheet(s) attached	
Examiner	/Jonathan Langman/		Date Considered 12/22/2009

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /JL/